

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KITAOKA et al.

Docket: 10873.1391US01

Title: METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND
SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.10

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By: _____
Name: John Junkers

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In connection with the above-identified application filed herewith, please enter
the following preliminary amendment:

Amendments to the claims are reflected in the listing of claims which begins on
page 2 of this paper

Remarks begin on page 7 of this paper.